020732-97.668 (7493)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

020732-97.668 Docket No.: In re United States Patent Application of: (7493)4823 Conf. No.: RATH, Melissa K., et al. Applicants: Art Unit: 1752 Application No.: 10/792,038 LE, Hoa Van Examiner: Date Filed: March 3, 2004 COMPOSITION AND PROCESS FOR Customer No.: Title: 24239 POST-ETCH REMOVAL OF PHOTORESIST AND/OR SACRIFICIAL ANTI-REFLECTIVE MATERIAL DEPOSITED ON A **SUBSTRATE** 

## UNOFFICIAL FACSIMILE TRANSMISSION Attn: Examiner Hoa Van Le Fax No. (571) 273-1332

I hereby certify that this document is being filed in the United States Patent and Trademark Office, via facsimile transmission to Examiner Lee's personal facsimile number on October 31, 2006.

Number of Pages (including cover)

Tristan A. Fuierer

October 31, 2006

Date

RESUBMISSION OF THE RESPONSE TO AUGUST 30, 2006 OFFICE ACTION IN UNITED STATES PATENT APPLICATION NO. 10/792,038

Mail Stop Amendment Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to a recent telephone call from Examiner Le, whereby he indicated that the USPTO only received 27 of the 30 pages of the response to the August 30, 2006 Office Action, applicants hereby resubmit said response. Applicants also submit that the original response to the Office Action did include all 30 pages, as indicated in the copy of the Auto-Reply certificate attached herewith in Appendix A.

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Please amend the claims, as set out in the following Section I (the Claims).

Remarks addressing the substance of the August 30 2006 Office Action are set out in the Section II (Remarks) hereof.